## **PATENT**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: ERIC J. BERGMAN

10/631,376

FILED: JULY 30, 2003

FOR: METHODS OF THINNING A SILICON WAFER

**USING HF AND OZONE** 

APPLICATION No.:

EXAMINER: Z. EL-ARINI

**ART UNIT: 1746** 

CONF. No: 2135

## **AMENDMENT**

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed 6/13/2006, please amend the Application as follows:

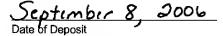
Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

[Continued on Next Page.]

## Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



Debbie Gilbert